



## PÁTENT

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

CYRILLE et al.

Examiner:

Culbert, R.

10/633,765

Group Art Unit:

1763

Filed:

August 4, 2003

Docket No.:

HSJ920030027US1

(HITG.025PA)

Title:

METHOD FOR PROVIDING A LIFTOFF PROCESS USING A SINGLE LAYER

RESIST AND CHEMICAL MECHANICAL POLISHING AND SENSOR

FORMED THEREWITH

CERTIFICATE UNDER 37 CFR 1.8: The undersigned hereby certifies that this correspondence and the papers, as described hereinabove, are being deposited in the United States Postal Service, as first class mail, in an envelope addressed to: Mail Stop Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on October 27, 2005.

David W. Lynch

## **REQUEST FOR RECONSIDERATION**

MAIL STOP AMENDMENT Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir:

In response to the Office Action dated July 27, 2005, reconsideration and allowance of the application are respectfully requested in view of the remarks below.

Amendments to the claims begin on page 2 of this paper.

Remarks begin on page 6 of this paper.